

**List of Patents and Publications For  
Applicant's Information Disclosure Statement  
Docket No. 1150-20-CP  
Page 1 of 2**

Form PTO-1449 (Revised)  
(Use several sheets if necessary)

U.S. Serial No.: **Not yet Assigned** 101806,973

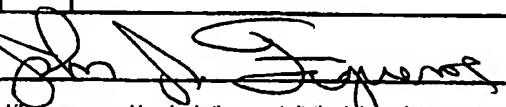
Group No.: ... **17/2**

U.S. Filing Date: **Herewith** 3/23/2004

Examiner: **Not yet Assigned** J. FIGUEROA

Applicant: **Jeno Muthiah**

CA 4.11.07

Reference Designation U.S. PATENT DOCUMENTS							
Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date (if appropriate)
JSF	AA	4,147,737	4/79	SEIN	525	438	
JSF	AB	4,686,108 Nason et al	8/87	Nason et al	427	470	
JSF	AC	4,868,059 Walker et al	7/87	Walker et al	428	416	
JSF	AD	5,168,110 Van Den Elshout et al	4/90	Van Den Elshout et al	525	438	12/1992
JSF	AE	5,169,473 Bertram et al	12/92	Bertram et al	156	307.1	
JSF	AF	5,270,416 Toman et al	12/93	Toman et al	524	904	
JSF	AG	5,304,332 Richart	4/94	Richart et al	264	255	
JSF	AH	5,344,672 Smith	7/94	Smith	427	195	
JSF	AI	5,436,311 Hoebeke et al	2/95	Hoebeke et al	525	174	
JSF	AJ	5,480,726 Richart	1/96	Richart	428	482	
JSF	AK	5,714,206 Daly et al	2/98	Daly et al	427	175	
Foreign Patent Documents							
		Document Number	Date	Country	Class	Sub-Class	Translation Yes No
JSF	AS	EPO Publ. No. 0933140-A1	8/99	EP	—	—	
JSF	AT	PCT Publ. No. W098/58748	12/98	PC5	—	—	
JSF	AU	EPO Appl. No. 0 214 448-A2	7/88	EP	—	—	
				3/87			
Other Art (including author, title, date, pertinent pages, etc.)							
Examiner 				Date Considered <b>June 23, 2006</b>			
Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

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**List of Patents and Publications For  
Applicant's Information Disclosure Statement  
Docket No. 1150-20-CP  
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Form PTO-1443 (Modified)  
(Use several sheets if necessary)

U.S. Serial No.: **Not yet Assigned**

Group No.: ---

U.S. Filing Date: **Herewith**

Examiner: **Not yet Assigned**

Applicant: **Jeno Muthiah**

Reference Designation U.S. PATENT DOCUMENTS							
Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date (if appropriate)
JSF	AL	5,721,052 Muthiah et al	2/98	Muthiah et al	428	413	
	AM	5,731,043 Horinka et al	3/98	Horinka et al	428	413	
	AN	5,824,373 Bitter et al	10/98	Bitter et al	530	311	
	AO	5,922,473 Muthiah et al	7/99	Muthiah et al	428	413	
	AP	6,048,949 Muthiah et al	4/00	Muthiah et al	525	438	
	AO	6,077,610 Correll et al	6/00	Correll et al	428	413	
	AR	6,113,980 Laver	9/00	Laver et al	427	207.1	
	AW	6,360,974 B1 Sacharski et al	3/02	Sacharski et al	241	16	
JSF	AX	6,294,610 B1 Daly et al	9/01	Daly et al	525	119	
	AY	6,113,980					
JSF	AZ	6,025,030 Decker et al	2/00	Decker et al	427	386	
Foreign Patent Documents							
		Document Number	Date	Country	Class	Sub-Class	Translation Yes No
JSF	AV	EPO Publ. No. 0148637-A1	12/84	EP			
Other Art (including author, title, date, pertinent pages, etc.)							
Examiner	[Signature]			Date Considered June 23, 2006			
Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							